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Docket: 0756-1614

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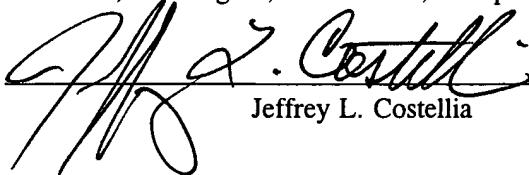
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M.R.

CERTIFICATE OF MAILING

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Jeffrey L. Costellia

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GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Takeshi FUKUNAGA et al.)
Serial No. 08/781,920) Art Unit: 1762
Filed: December 30, 1996) Examiner: M. Padgett
For: METHOD OF FABRICATING A)
SEMICONDUCTOR DEVICE)
UTILIZING A CATALYST)
MATERIAL SOLUTION) Date: April 21, 1999

AMENDMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed December 21, 1998, please amend the subject application as follows.

04/27/1999 NHASSANI 00000072 08781920

01 FC:103
02 FC:115

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110.00 OP